

Notice of References Cited	Application/Control No. 10/710,887	Applicant(s)/Patent Under Reexamination LIU ET AL.	
	Examiner W. Patty Chen	Art Unit 2871	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	C	US-2004/0041976	03-2004	Kida et al.	349/187
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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